

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Nobuo SHIMIZU; Shinichi YOTSUYA; Hideto Group Art Unit:
YAMASHITA; Masami MURATA; Koichi AKIYAMA

Application No.: New Rule 53(b) Continuation of U.S. Examiner:
Application No. 09/828,831

Filed: July 8, 2003

Docket No.: 109214.01

For: A SYSTEM AND METHOD FOR PROVIDING A SUBSTRATE HAVING MICRO-
LENSES

INFORMATION DISCLOSURE STATEMENT

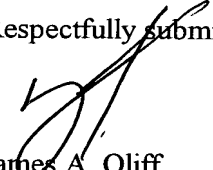
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The references were cited by or submitted to the Office in parent application No. 09/828,831, filed April 10, 2001, which is relied upon for an earlier filing date under 35 U.S.C. §120. Thus, copies of these references are not attached. 37 CFR §1.98(d).

Respectfully submitted,


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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 109214.01		APPLICATION NO. New Rule 53(b) Continuation of U.S. Application No. 09/828,831	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT(S) Nobuo SHIMIZU et al.			
				FILING DATE July 8, 2003		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
		4,074,933	02/1978	YEVICK ✓			
		6,129,866	10/2000	HAMANAKA ✓			
		6,363,603	04/2002	NEMOTO ✓			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
		JP-A-5-346577 (w/English abstract)	12/27/93	Japan ✓			
		JP-A-7-181487 (w/English abstract)	07/21/95	Japan ✓			
		JP-A-7-199188 (w/English abstract)	08/04/95	Japan ✓			
		JP-A-8-15687 (w/English abstract)	01/19/96	Japan ✓			
		JP-A-9-269483 (w/English abstract)	10/14/97	Japan ✓			
		JP-A-11-24060 (w/English abstract)	01/29/99	Japan ✓			
		JP-7-17490 (w/English abstract)	01/1995	Japan ✓			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							